



PATENT
Docket No.: Q106-US1

UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Hisashi Tsukamoto et al. :
Application No.: 10/031,022 : Group Art Unit: 1734
Filing Date: January 14, 2002 : Examiner: N/A
Title: LITHIUM THIN FILM :
LAMINATION TECHNOLOGY :
ON ELECTRODE TO INCREASE :
BATTERY CAPACITY :

CERTIFICATE OF MAILING VIA
CERTIFIED FIRST CLASS MAIL (37 CFR 1.8)
Dated April 18, 2002

Assistant Commissioner for Patents,
Washington, D.C. 20231

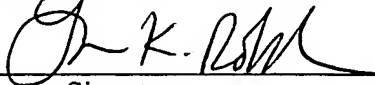
I hereby certify that the following attached documents are being deposited with the United States Postal Service as first class certified mail under 37 CFR 1.8 on the date indicated above and are addressed to Assistant Commissioner for Patents, Washington, D.C. 20231.

1. Transmittal Letter for Information Disclosure Statement (in duplicate)
2. Information Disclosure Statement
3. PTO Form 1449 with copies of cited references
4. Self addressed stamped return postcard

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April 18, 2002
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